

S/N 09/858,337

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	William J. Schaff et al.	Examiner:	Khanh Duong
Serial No.:	09/858,337	Group Art Unit:	2822
Filed:	May 15, 2001	Docket No:	1153.044US1
Title	AIN COATED HETEROJUNCTION FIELD EFFECT TRANSISTOR AND METHOD OF FORMING AN AIN COATING		

PETITION FOR A FURTHER TWO-MONTH EXTENSION OF TIME

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

In accordance with the provision of 37 CFR § 1.136(a), it is respectfully requested that a further two-month extension of time be granted in which to respond to the final Office Action mailed June 6, 2005, said period of response being extended from September 6, 2005 to December 6, 2005.


**Please charge Deposit Account No. 19-0743 in the amount of \$450.00 to cover the required extension fee. Please charge any additional fees or credit overpayment to deposit Account No. 19-0743.**

Respectfully Submitted

WILLIAM J. SCHAFF ET AL.

By their Representatives,

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.  
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Date: 11/23/2005 By:   
Bradley A. Forrest  
Reg. No: 30,837

CERTIFICATE UNDER 37 CFR § 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 23<sup>rd</sup> day of November 2005.

Name: 

Signature: 

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